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FAX

Date	February 3, 2006		
То	Examiner Michael E. Lavilla		
Of	PTO Group Art Unit 1775		
Fax	571-273-8300		
From	Mr. Ron Kimble		
Subject	Supplemental Amendment Under 37 C.F.R. § 1.111		
Our Ref	Q67726	Appin No	10/009,822
Conf No	6202	Inventors	Mitsuo OSADA, et al.
Pages	(including cover sheet)		

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This fax filing includes:

- 1. This cover sheet
- 2. Supplemental Preliminary Amendment

CERTIFICATION OF FACSIMILE TRANSMISSION

Sir.

I hereby certify that the above identified correspondence is being facsimile transmitted to Examiner Michael E. Lavilla at the Patent and Trademark Office on February 1, 2006 at 571-273-8300.

Respectfully submitted

Sandra L.Su



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q67726

Mitsuo OSADA, et al.

Appln. No.: 10/009,822

Group Art Unit: 1775

Confirmation No.: 6202

Examiner: Michael E. Lavilla

Filed: December 13, 2001

For:

MATERIAL FOR A HEAT DISSIPATION SUBSTRATE FOR MOUNTING A SEMICONDUCTOR, METHOD OF PRODUCING THE SAME, AND CERAMIC

PACKAGE USING THE SAME

SUPPLEMENTAL AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to telephone discussions with the Examiner kindly pointing out administrative errors in Applicants' December 2, 2005 Amendment, please amend the above-identified application as follows on the accompanying pages.